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Global solutions of singular parabolic equations arising from electrostatic MEMS

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Abstract

We study dynamic solutions of the singular parabolic problem

$$\begin{cases} u_t - \Delta u = \frac{\lambda_* |x|^{\alpha}}{(1 - u)^2}, & (x, t) \in B \times (0, \infty), \\ u(x, 0) = u_0(x) \geqslant 0, & x \in B, \\ u(x, t) = 0, & x \in \partial B, \end{cases}$$
(P)

where $\alpha \geqslant 0$ and $\lambda_* > 0$ are two parameters, and B is the unit ball $\{x \in \mathbb{R}^N \colon |x| \leqslant 1\}$ with $N \geqslant 2$. Our interest is focussed on (P) with $\lambda_* := \frac{(2+\alpha)(3N+\alpha-4)}{9}$, for which (P) admits a singular stationary solution in the form $S(x) = 1 - |x|^{\frac{2+\alpha}{3}}$. This equation models dynamic deflection of a simple electrostatic Micro-Electro-Mechanical-System (MEMS) device. Under the assumption $u_0 \leqslant S(x)$, we address the existence, uniqueness, regularity, stability or instability, and asymptotic behavior of weak solutions for (P). Given $\alpha^{**} := \frac{4-6N+3\sqrt{6}(N-2)}{4}$, in particular we show that if either $N \geqslant 8$ and $\alpha > \alpha^{**}$ or $2 \leqslant N \leqslant 7$, then the minimal compact stationary solution u_{λ_*} of (P) is stable and while S(x) is unstable. However, for $N \geqslant 8$ and $0 \leqslant \alpha \leqslant \alpha^{**}$, (P) has no compact minimal solution, and S(x) is an attractor from below not from above. Furthermore, the refined asymptotic behavior of global solutions for (P) is also discussed for the case where $N \geqslant 8$ and $0 \leqslant \alpha \leqslant \alpha^{**}$, which is given by a certain matching of different asymptotic developments in the large outer region closer to the boundary and the thin inner region near the singularity. © 2008 Elsevier Inc. All rights reserved.

Keywords: MEMS; Existence and uniqueness; Asymptotic behavior; Minimal solutions; Stability

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1. Introduction

The singular parabolic problem

$$\begin{cases} u_t - \Delta u = \frac{\lambda f(x)}{(1-u)^2}, & (x,t) \in \Omega \times (0,\infty), \\ u(x,0) = u_0(x) \geqslant 0, & x \in \Omega, \\ u(x,t) = 0, & x \in \partial \Omega, \end{cases}$$

$$(1.1)$$

was recently proposed in [11,14], where $\lambda > 0$ is a parameter, $\Omega \subset \mathbb{R}^N$ is a bounded smooth domain and f(x) is a nonnegative function satisfying

$$f \in C^{\alpha}(\bar{\Omega})$$
 for some $\alpha \in (0, 1], \ 0 \leqslant f \leqslant 1$, and $f > 0$ on a subset of Ω of positive measure. (1.2)

When N=1 or 2, this equation models a simple electrostatic Micro-Electro-Mechanical-System (MEMS) device consisting of a thin dielectric elastic membrane with boundary supported at 0 below a rigid plate located at +1. The dynamic solution u(x,t) of (1.1) characterizes the dynamic deflection of the elastic membrane. When a voltage—represented here by λ —is applied to the surface of the membrane, the membrane deflects towards the ceiling plate and a snap-through may occur when it exceeds a certain critical value λ^* (pull-in voltage). This creates a so-called "pull-in instability" which greatly affects the design of many devices. In an effort to achieve better MEMS designs, the material properties of the membrane can be technologically fabricated with a spatially varying dielectric permittivity profile f(x) (see [11,14] and references therein for more detailed discussions on MEMS devices).

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